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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Tomohiro TAKAMATSU et al.**

Group Art Unit: **2826**

Application Number: **10/695,643**

Examiner: **Fazli Erdem**

Filed: **October 29, 2003**

Confirmation No.: **5393**

For: **SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD
OF A SEMICONDUCTOR DEVICE**

Attorney Docket Number: **032057**

Customer Number: **38834**

AMENDMENT AFTER FINAL REJECTION

Mail Stop AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

January 28, 2009

Sir:

This paper is filed in response to the Office Action dated October 29, 2008.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.